

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q86579

Takanori MIYASAKA, et al.

Appln. No.: 10/526,031

Group Art Unit: 2856

Confirmation No.: 4777

Examiner: Unknown

Filed: February 28, 2005

For:

MACHINERY FACILITY CONDITION MONITORING METHOD AND SYSTEM

AND ABNORMALITY DIAGNOSIS SYSTEM

PRELIMINARY AMENDMENT

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE SPECIFICATION	2
AMENDMENTS TO THE CLAIMS	
AMENDMENTS TO THE DRAWINGS	
REMARKS	55